

Sheet 1 of 1

Form PTO-1449

INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION

Doctos Number (Optional)  
CMM-00202

Application Number  
10/042,936

Use several sheets if necessary

FEB 9 2002

FEB 20 2002

Jerome LONG, et al.

Filing Date  
January 9, 2002

Group Art Unit

**U.S. PATENT DOCUMENTS**

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PTO/SB/08A (10-01)

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Substitute for form 1449A/PTO				<b>Complete if Known</b>	
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> (use as many sheets as necessary)				Application Number	10/042,936
				Filing Date	January 9, 2002
				First Named Inventor	Long et al.
				Art Unit	To Be Assigned
				Examiner Name	To Be Assigned
Sheet	1	of	1	Attorney Docket Number	801939/112

U.S. PATENT DOCUMENTS					
Examiner Initials <sup>1</sup>	Cite No. <sup>1</sup>	U.S. Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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Ayul	1	George et al., "Delaunay Triangulation and Meshing," <i>Hermes</i> , Paris 33-238 (1998) Delaunay triangulation: 33-46, 50-59; Constrained triangulation: 73-99; Parametric surface meshing: 161-173; Optimizations: 215-238			
	Ayul	2		Dahlquist, et al., "Numerical Methods," <i>Prentice Hall</i> 284-355 (1974) Interpolation: 284-285; Linear Solver: 146-172; Time-Dependent Solver: 347-355 Eigenvalue Solver: 208-211; Damped Newton Method: 248-253	
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Ayul			4	Frey et al., "Mesh Generation, Application to Finite Elements," <i>Hermes</i> , Paris 88-90 (2000) Mesh Search: 88-90	
	Ayul	5	Zienkiewicz et al., "The Finite Element Method," <i>McGraw-Hill</i> 1:23-177 Basis Function: 23-26; Quadrature Formulas, Gauss Points, Weights: 175-177		
Ayul		6	Davenport et al., "Computer Algebra Systems and Algorithms for Algebraic Computation," <i>Academic Press</i> 28-32 (1993) Symbolic Differentiation: 28-32		
	Ayul	7	C. Johnson, "Numerical Solution of Partial Differential Equations by the Finite Element Method," <i>Studentlitteratur</i> 14-18 (1987) Test Function 14-18		

Examiner Signature	Ayul Sharon	Date Considered	8/4/05
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